

Special Issue

MEMS and Piezoelectric Sensors for Biomedical Applications

Message from the Guest Editors

This Special Issue focuses on advanced MEMS and piezoelectric sensors research for the vital sign monitoring of wearable devices, emphasizing their advantages for wearable device design. Furthermore, the issue analyzes the contribution of continuous vital sign monitoring to the research in biomedicine and the advantages of compact wearable device design for health technology. Our primary goal is to collect research and review articles that include novel wearable device designs, scientific method-based analyses, and contributions to the biomedical field and medical technology. We look forward to receiving your submissions!

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Deadline for manuscript submissions

closed (31 December 2023)



Micromachines

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Impact Factor 3.0
CiteScore 6.0
Indexed in PubMed



mdpi.com/si/161307

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